



A Low Cost MEMS Gravimeter

Abhinav Prasad

Institute for Gravitational Research

SUPA, University of Glasgow

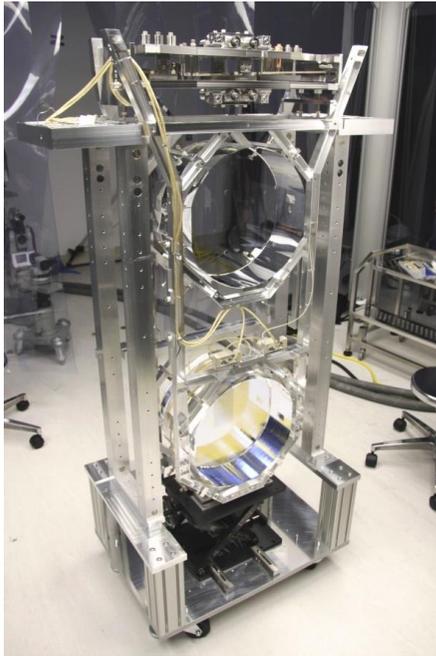
Abhinav.Prasad@glasgow.ac.uk

Giles.Hammond@glasgow.ac.uk

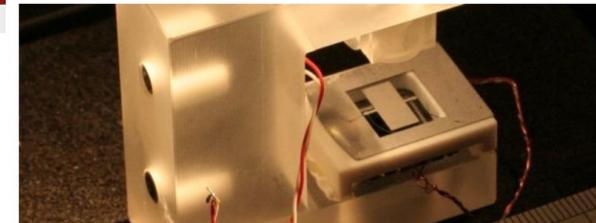
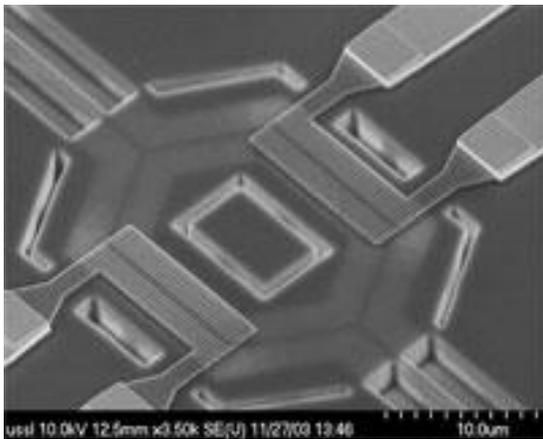
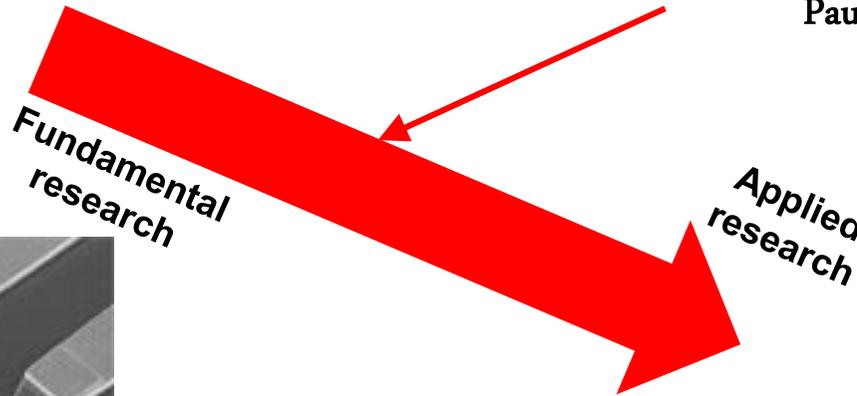
A. Prasad, R. P. Middlemiss, S. Bramsiepe, A. Noack, M. Aftalion, M. Sinclair, G. A. Marocco, J. Hough, S. Hild, S. Rowan, D. J. Paul & G. D. Hammond,



Institute for Gravitational Research
(<https://www.physics.gla.ac.uk/igr/>)



Paul Instrument Fund



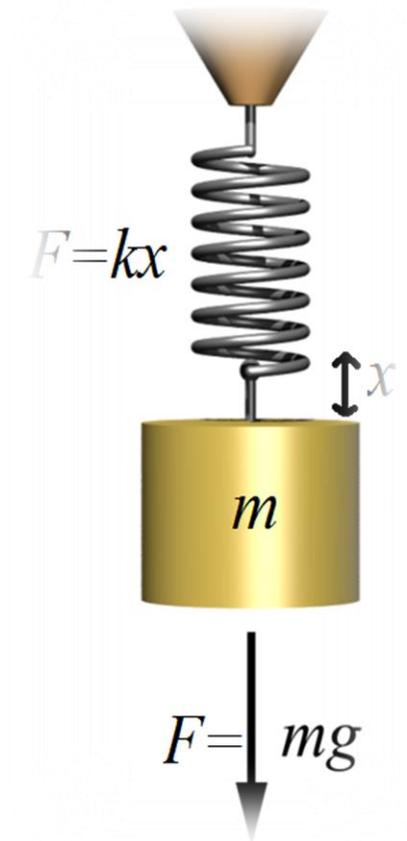
James Watt Nanofabrication Centre
(<http://www.jwnc.gla.ac.uk/about.html>)



UK Quantum Technology Hub in Enhanced Quantum Imaging (<https://quantic.ac.uk>)



- A gravimeter is a device which measures changes in the local gravitational acceleration ($1g = 9.81 \text{ m/s}^2$)
- Variation in local density causes changes at the level up to 30 billionths of g

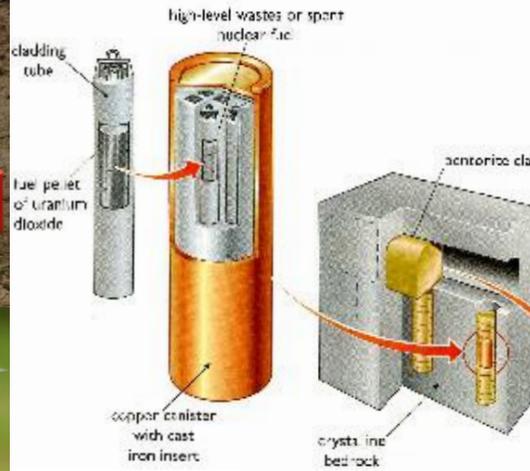


Gravity Imaging Applications

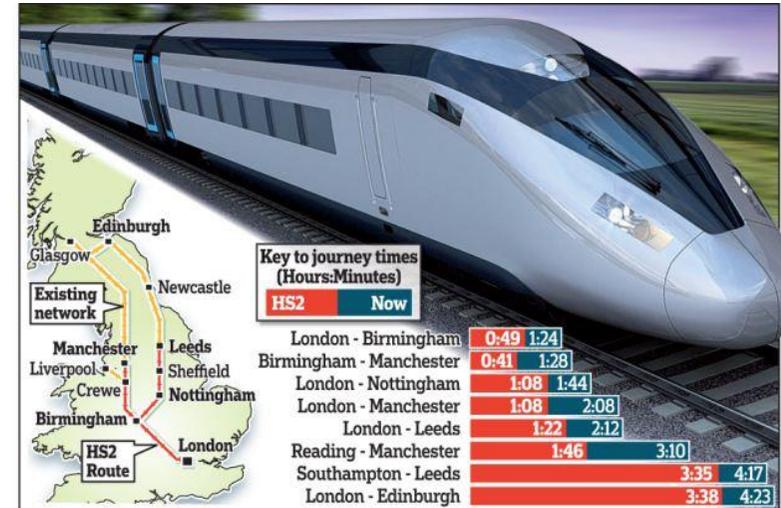
Oil & gas prospecting



Environmental monitoring



HS2



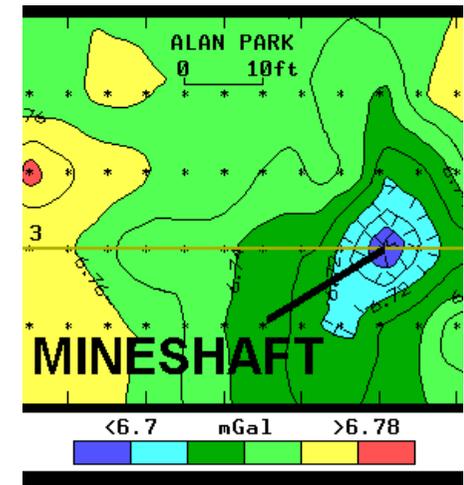
Security & Defence



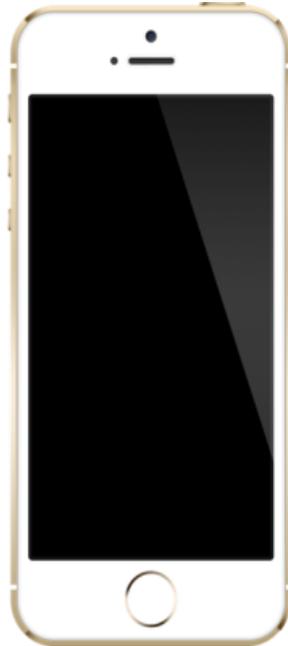
Volcano monitoring



Sink hole detection



iPhone



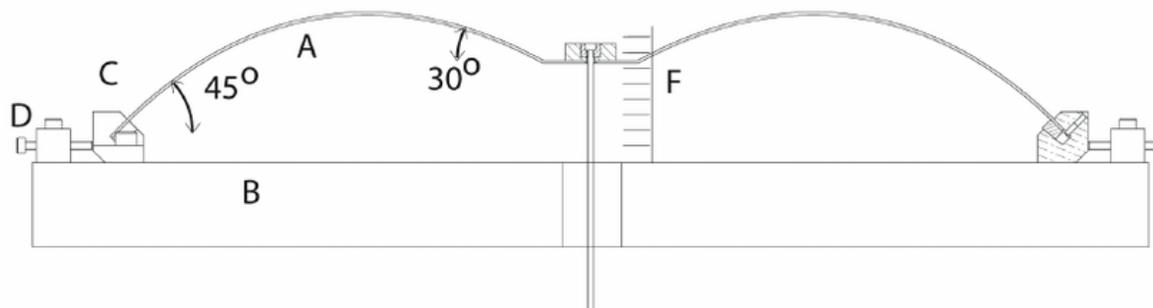
- Cheap but 10000 times too insensitive

CG-6

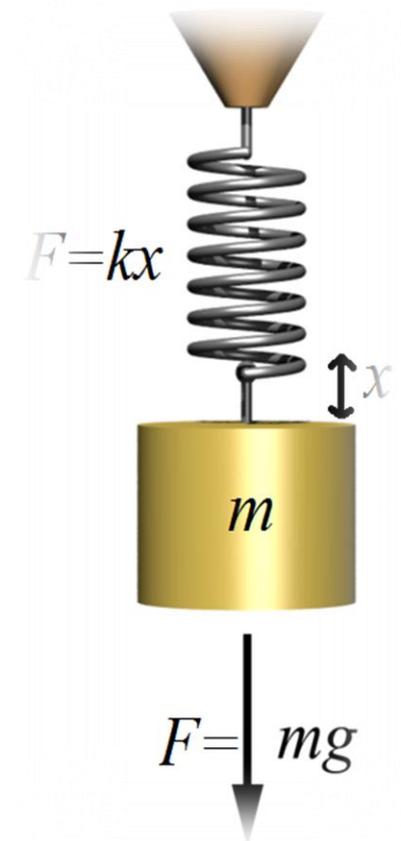


- Very good sensitivity but £70,000 (nano-g and sub nano-g sensitivity)

- A gravimeter is a device which measures changes in the local gravitational acceleration ($1g = 9.81 \text{ m/s}^2$)
- Variation in local density causes changes at the level up to 30 billionths of g
- This requires **a soft spring and a large mass**, **a very good displacement sensor**, or both
- A geometric anti-spring offers a very compact geometry which can be etched in silicon, providing a soft spring

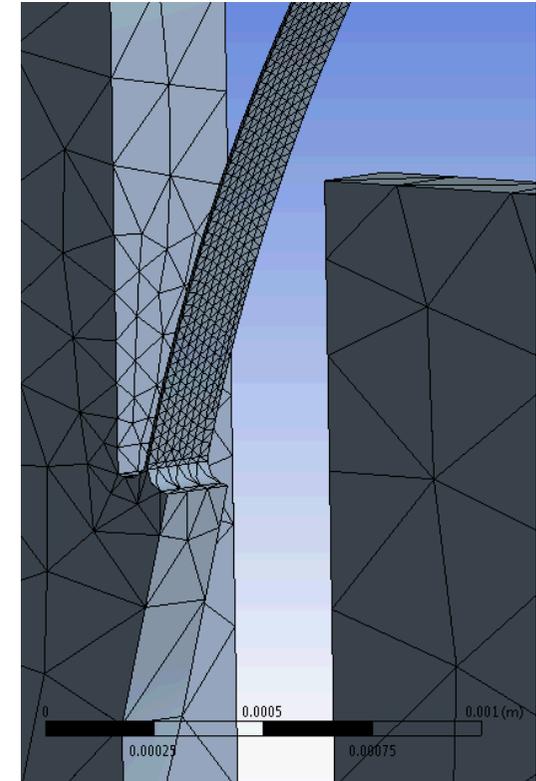
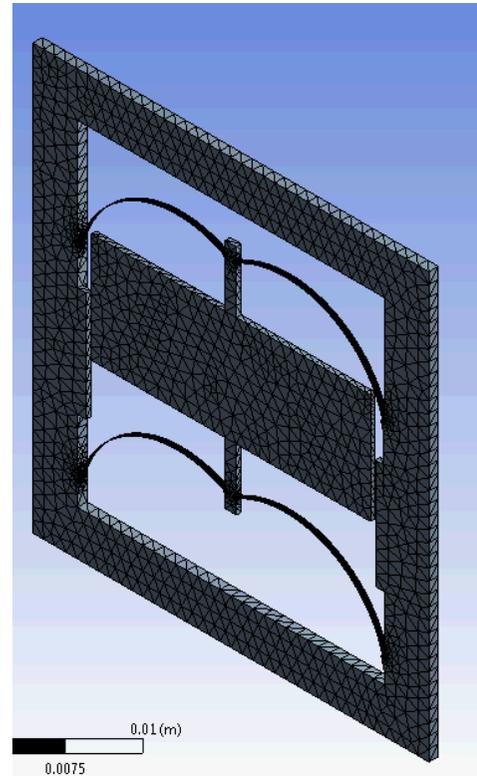
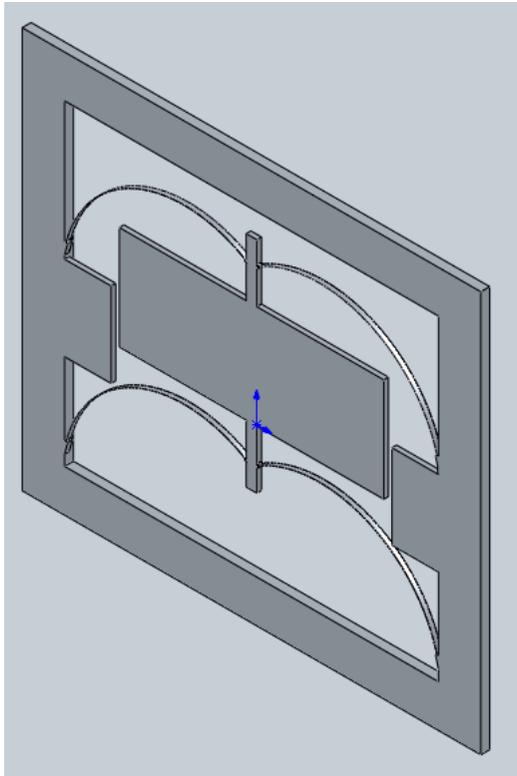


Geometric antisprings used in gravitational wave detectors (<https://arxiv.org/abs/gr-qc/0406091>)

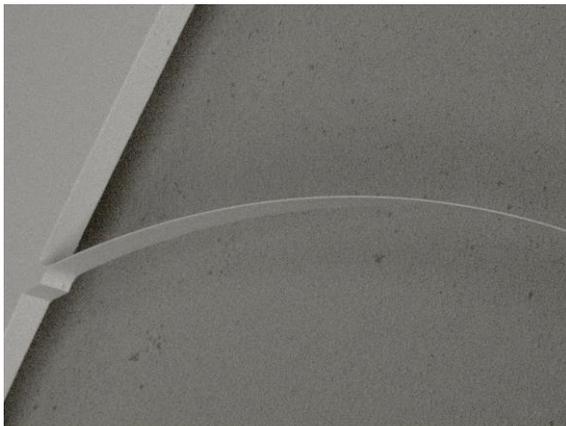
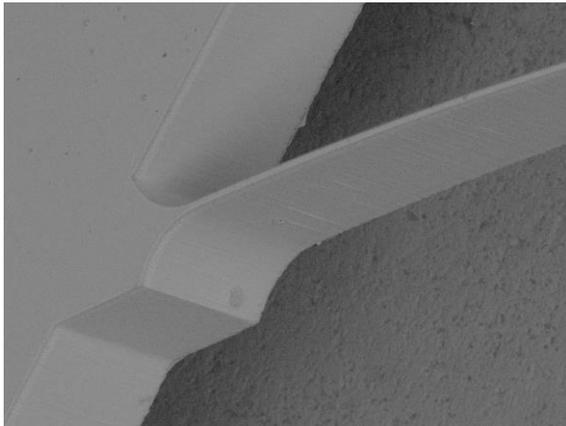


Geometric Antispring

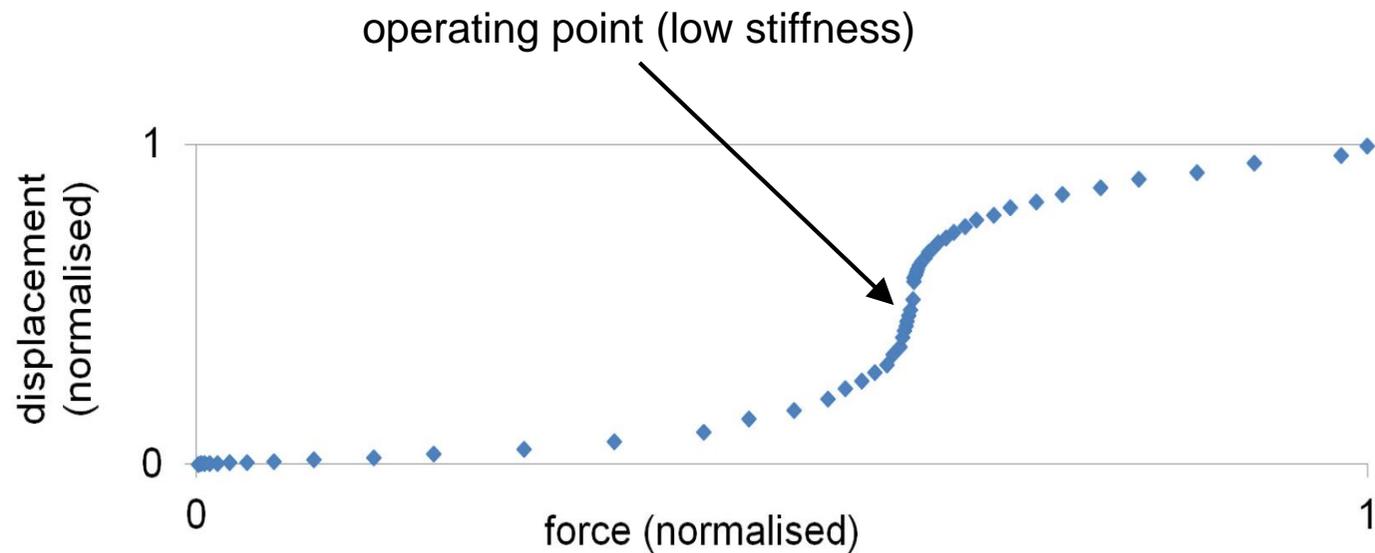
- Geometric antisprings used in gravitational wave detectors (VIRGO) for seismic isolation; springs that get softer as you load them



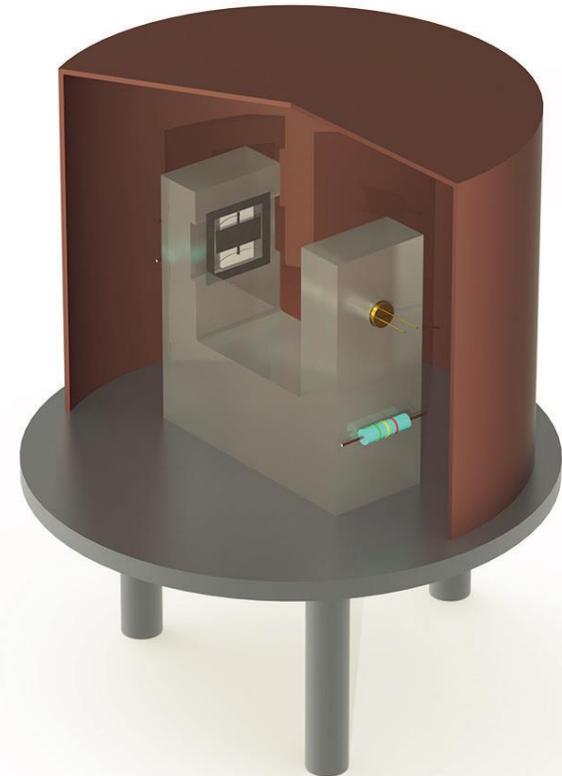
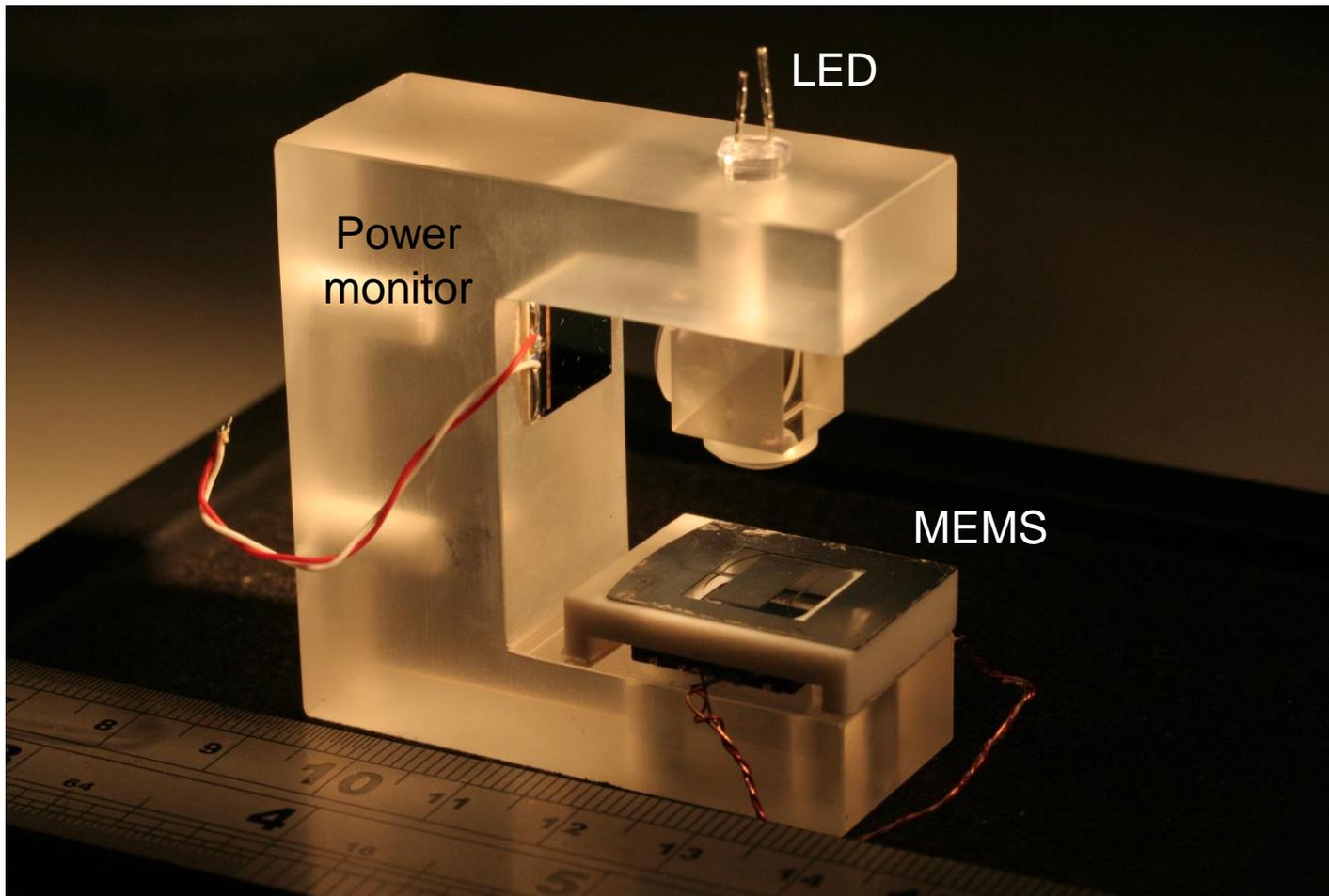
- We can build MEMS devices with 1Hz oscillation frequency and 0.02mg proof mass
- Excellent agreement between modelled proof mass displacement/frequencies and the measured ones



Silicon flexures are Deep-Reactive-Ion-Etched (DRIE); 220 μm thick and 9 μm wide



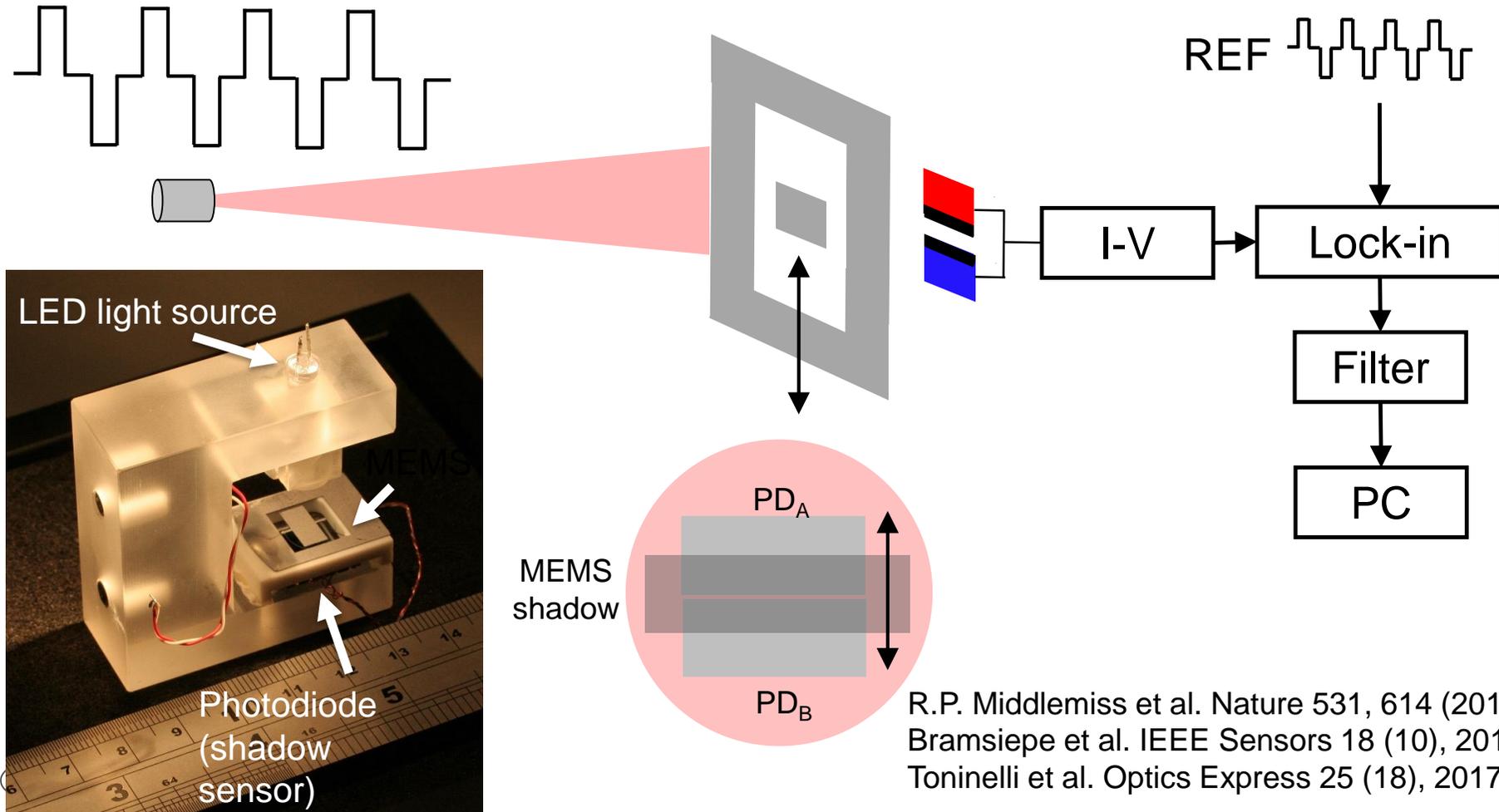
- We can build MEMS devices with 1Hz oscillation frequency and 0.02mg proof mass
- Excellent agreement between modelled proof mass displacement/frequencies and the measured ones



- Prototype built on fused silica structure for high thermal stability
- Thermal control of LED/MEMS/Outer shield required for nanometre precision over several days

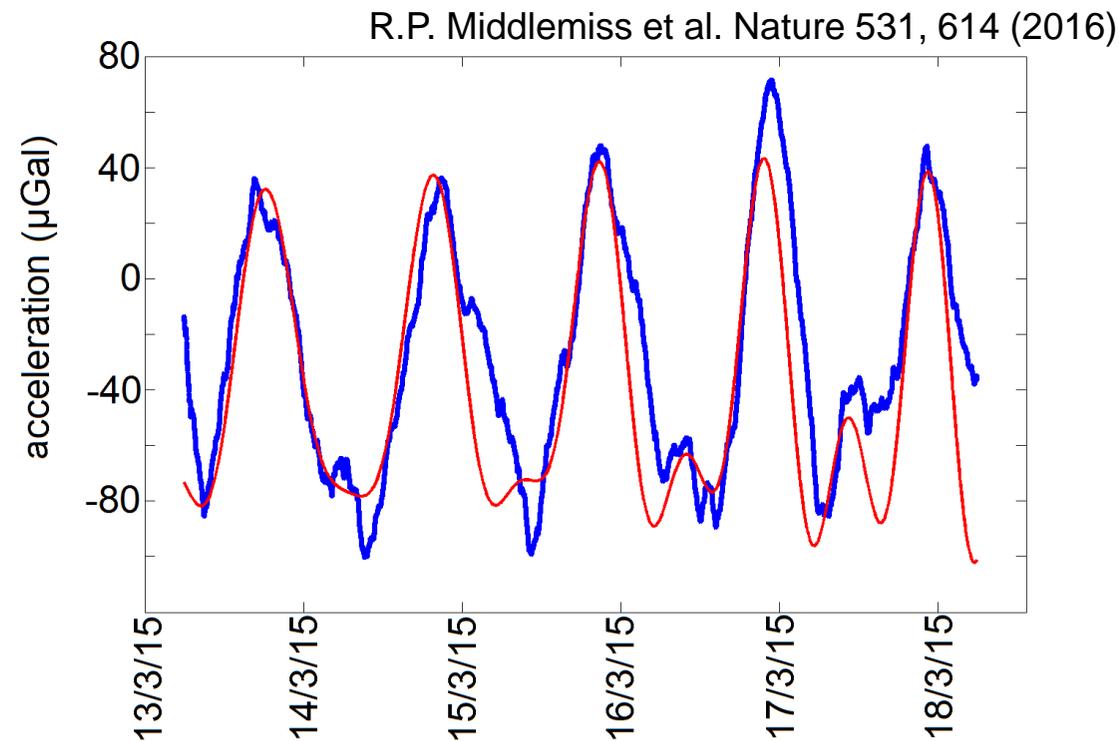
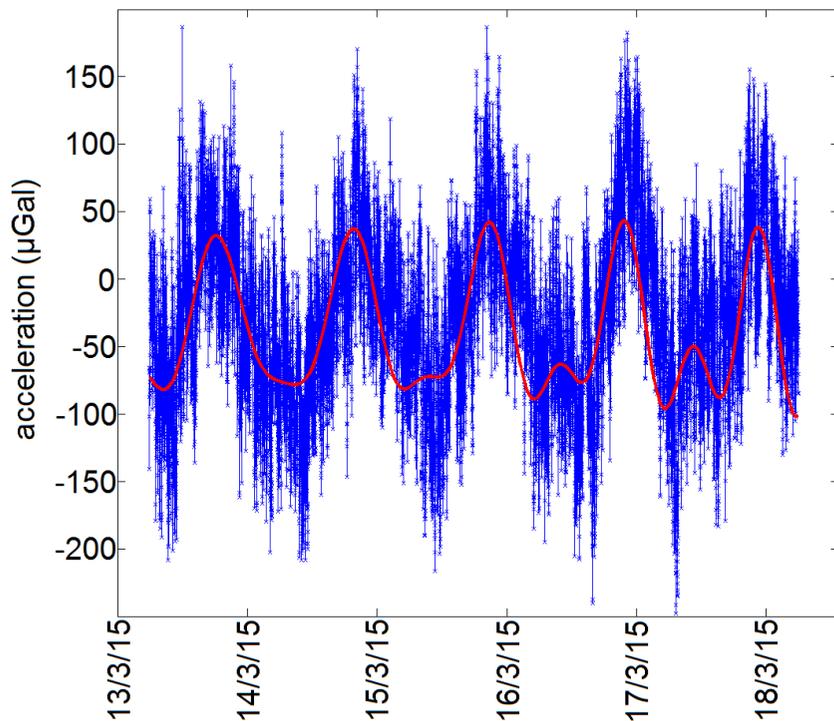
Optical Readout

- Developed a shadow sensor that can provide stability of $\pm 4\text{nm}$ over several days
- Split photodiode provides zero output at shadow centre, and immunity to relative intensity noise



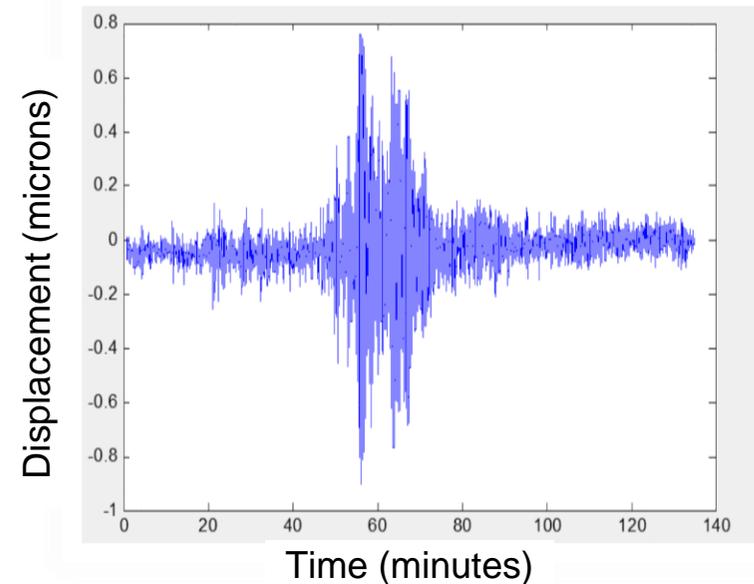
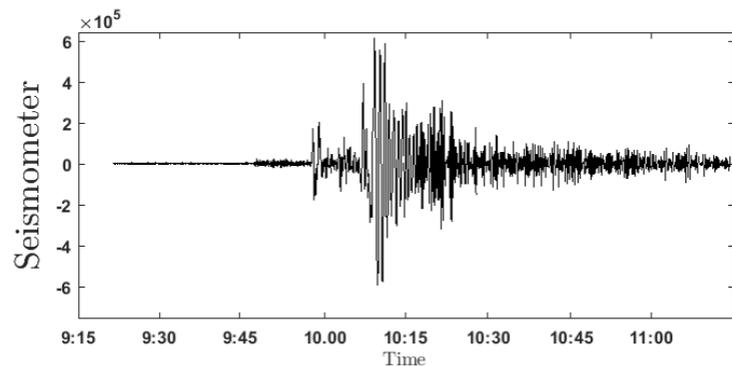
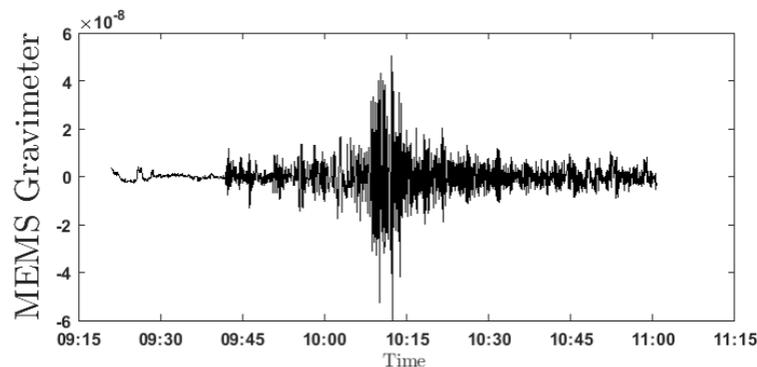
R.P. Middlemiss et al. Nature 531, 614 (2016)
Bramsiepe et al. IEEE Sensors 18 (10), 2018
Toninelli et al. Optics Express 25 (18), 2017

- There is a daily/twice-daily change in the local acceleration of gravity due to the Earth-Moon tidal gravitational potential ($250\mu\text{Gal} \approx 250\text{ng}$ maximum variation)
 - due to changing shape of solid earth (Earth tides; 30cm-40cm change in radius)
- This is a good signal to test long term stability. Measured during 2015-2016
- We demonstrated a sensitivity of $40\text{ng}/\sqrt{\text{Hz}}$



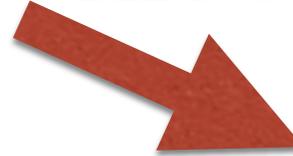
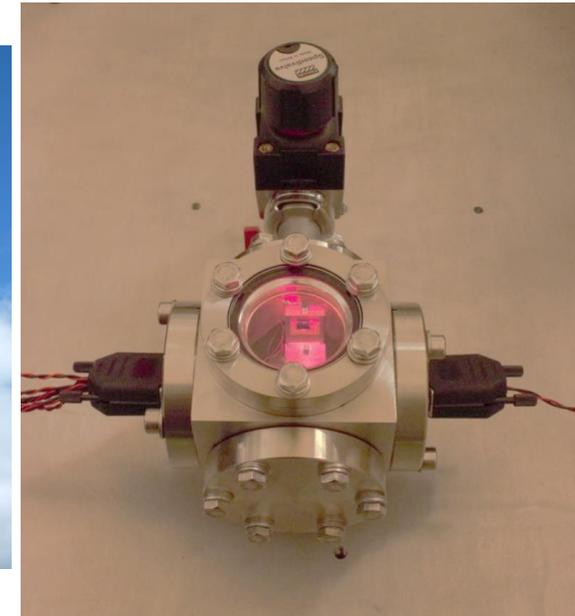
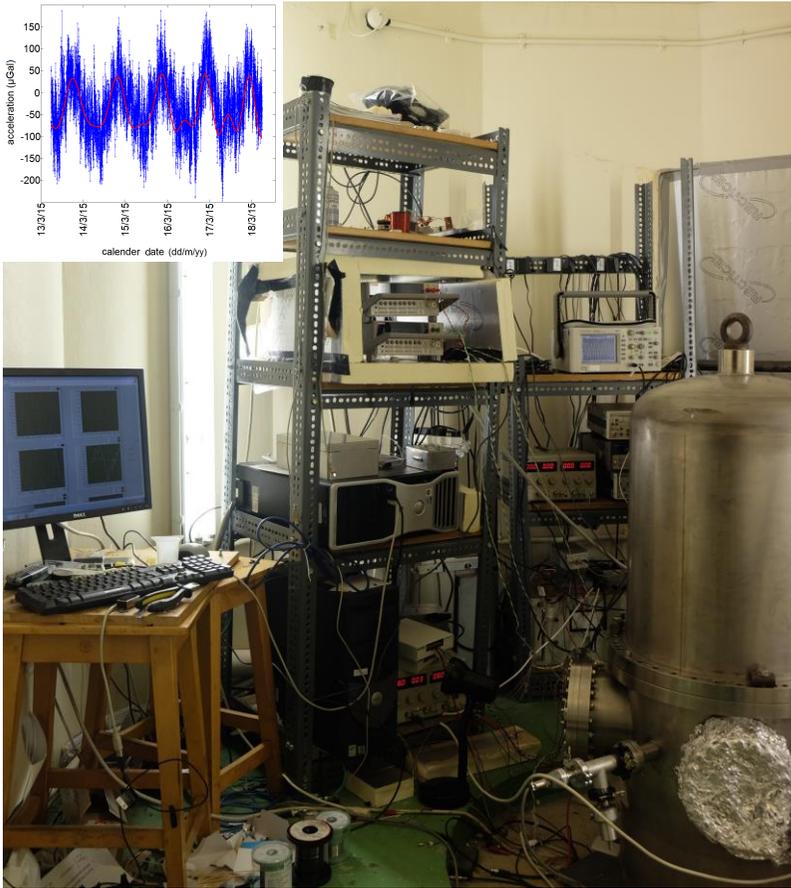
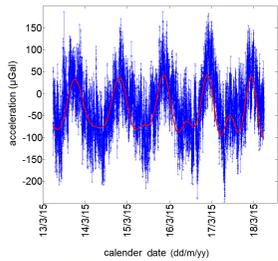
$$1 \mu\text{Gal} = 1 \text{ cm/s}^2 = 0.01 \text{ m/s}^2$$

- The device can be operated over a wide range of frequencies (5 orders of magnitude): seismometer-accelerometer-gravimeter



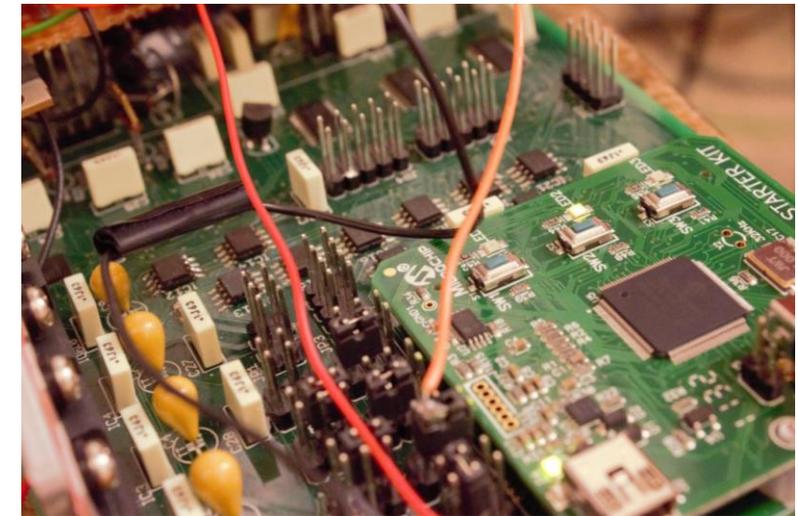
Chile 7.6 mag. earthquake
measured on 25th Dec, 2016

Alaska 7.9 magnitude
earthquake measured on
23rd Jan, 2018



2015: lab based system with
mains power, rack mount
electronics

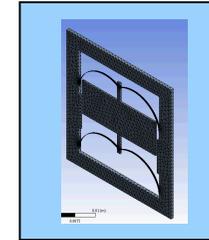
Bramsiepe et al. IEEE Sensors 18 (10), 2018



2016: shoebox sized field
demonstrator, battery power

2017 Field Tests: In a Lift

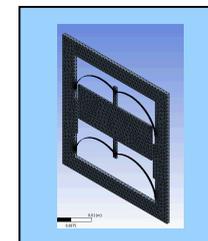
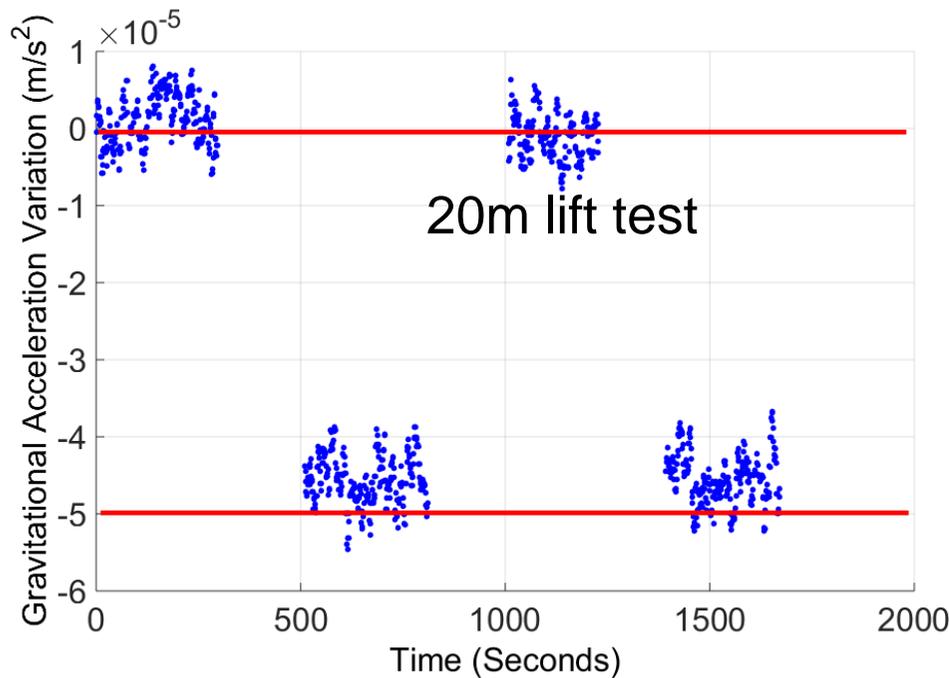
R. P. Middlemiss et al, Sensors **2017**, 17, 2571.



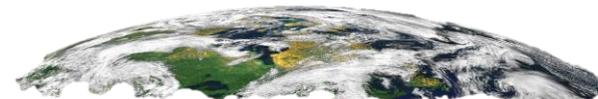
9.80994m/s²

20m

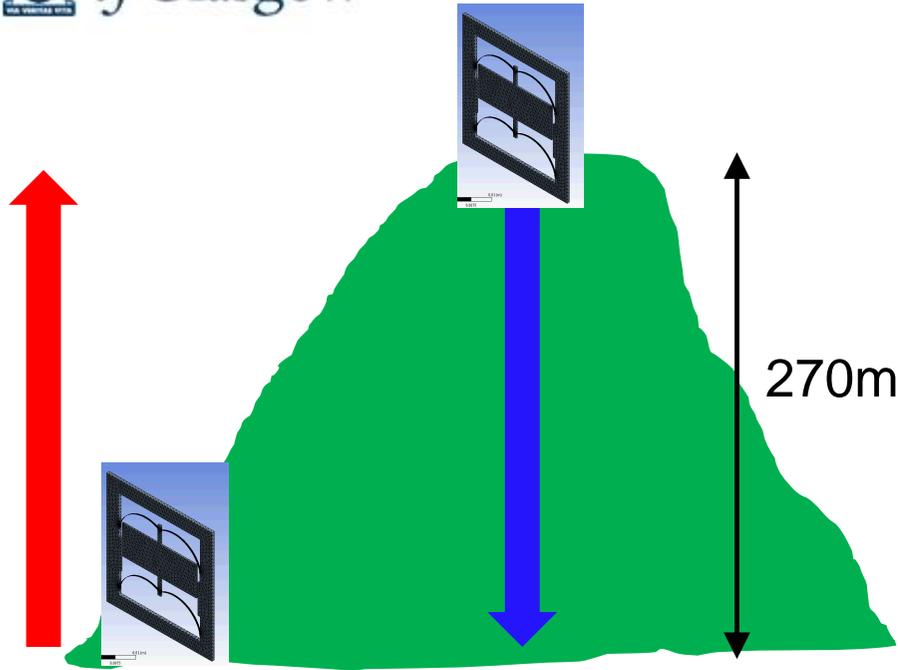
$$g = \frac{GM}{R_{Earth}^2}$$



9.810000m/s²

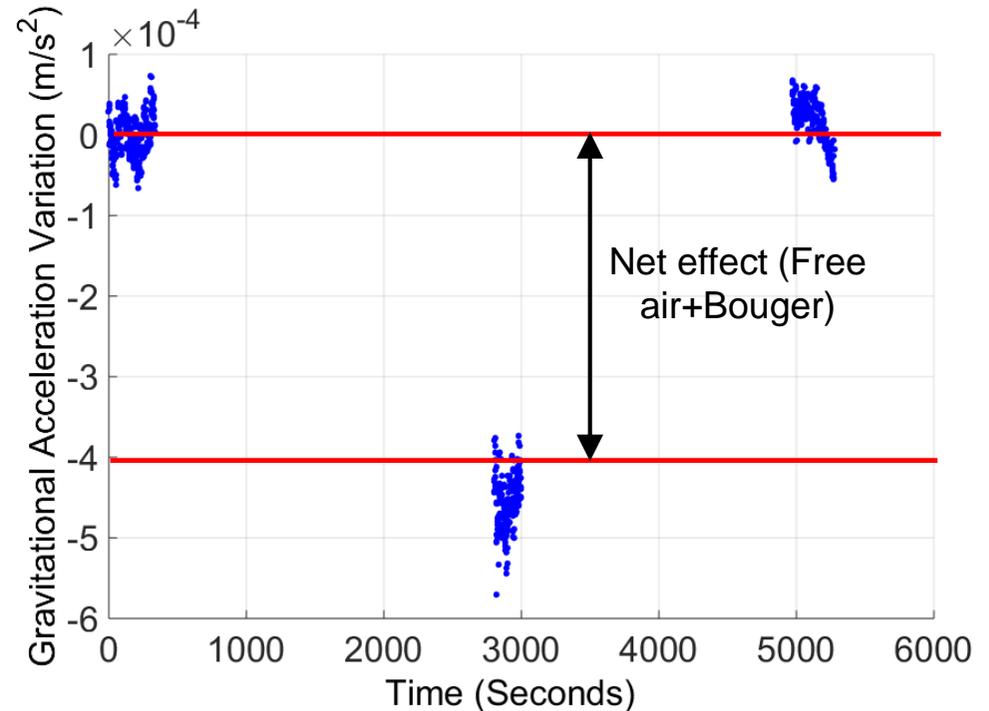
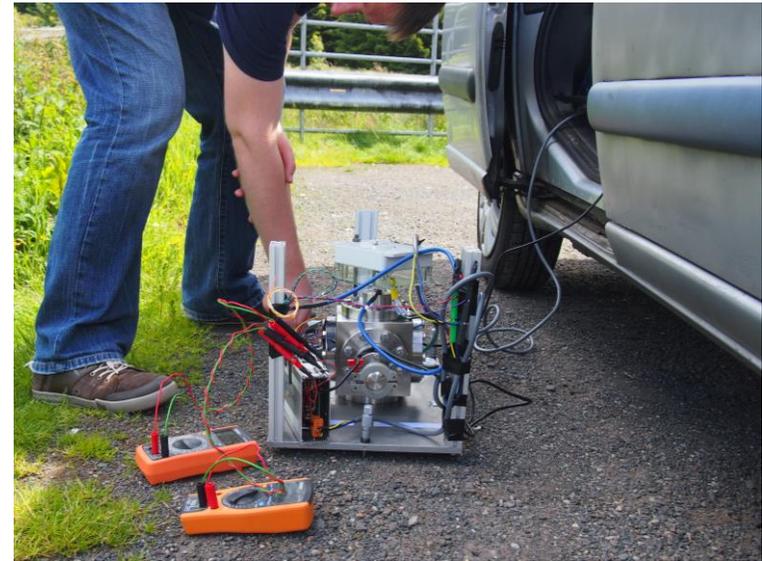


2017 Field Tests: Up a Hill

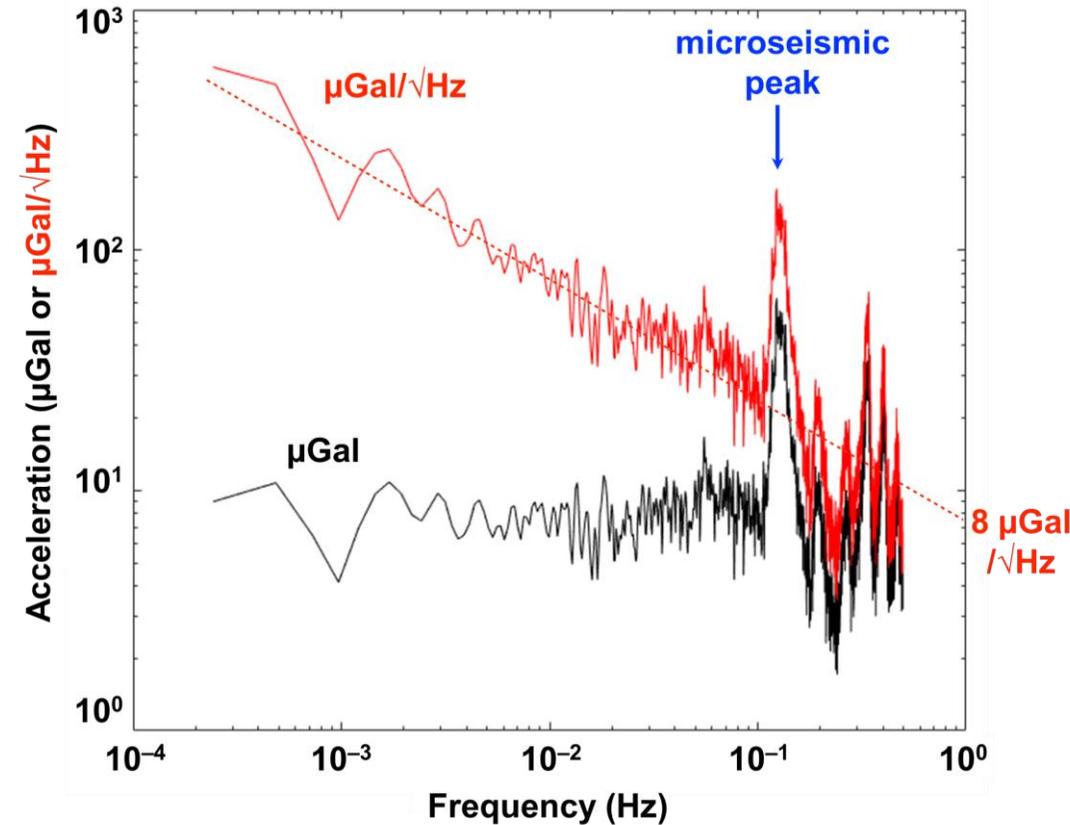
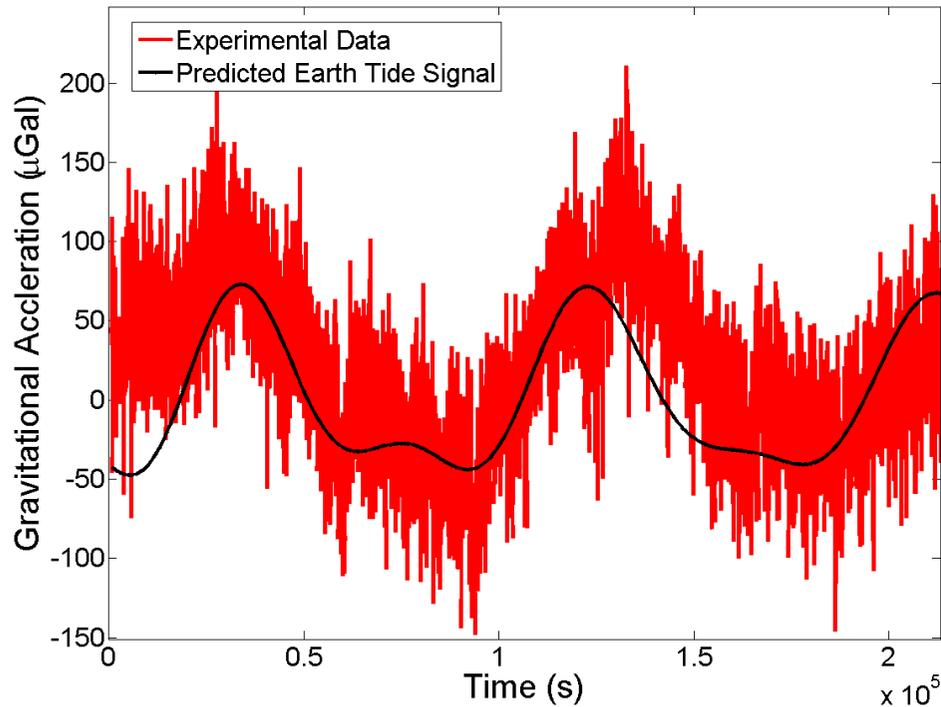


g reduces as moving away from earth (free air effect)

g increases as sitting on local rock (Bouger effect)

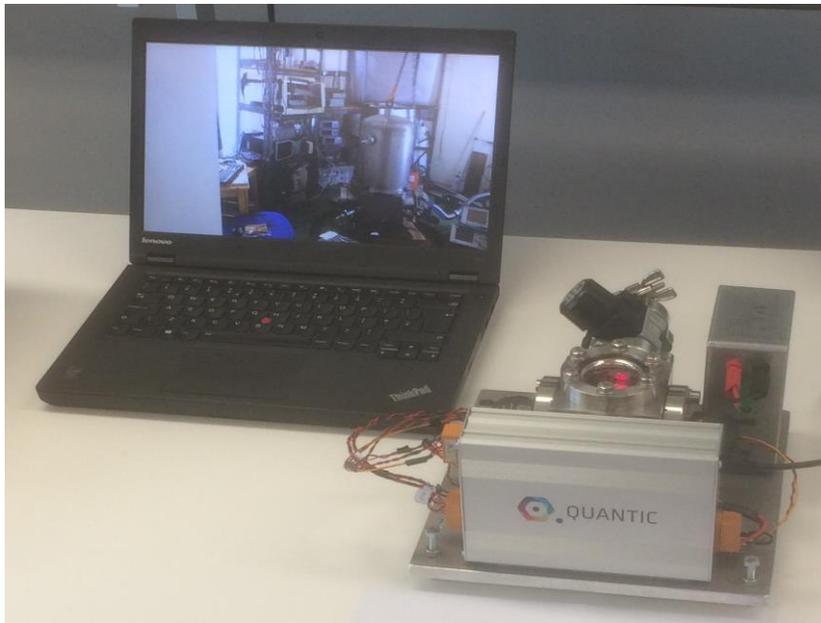


270m altitude change (Campsie Hills)



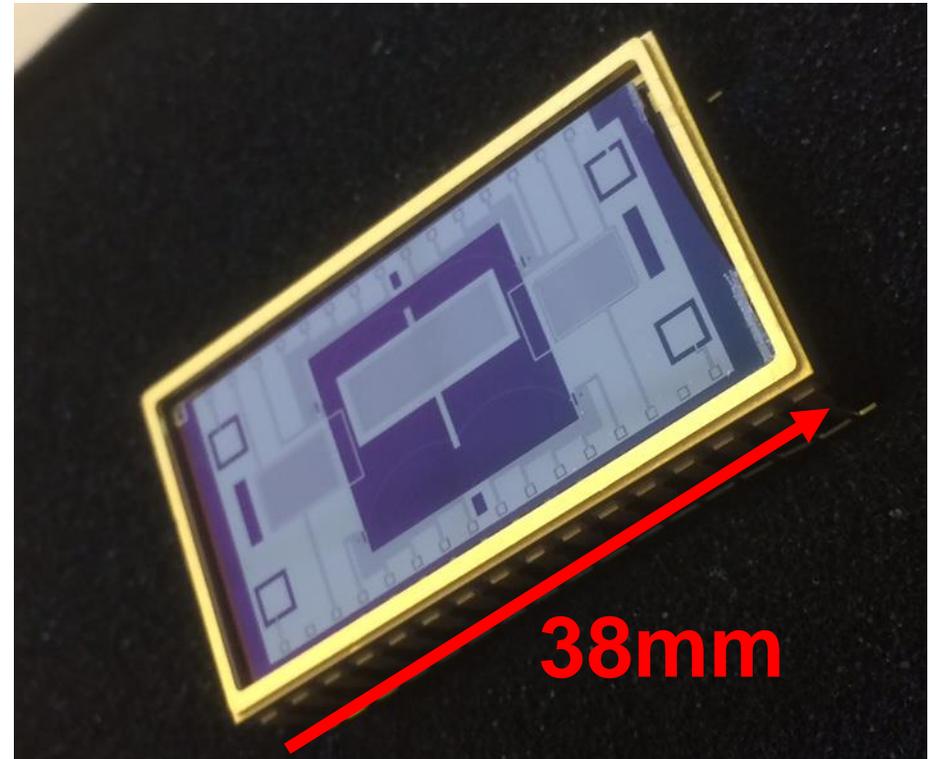
10 kg, 3.2 W, 15 hours battery
 ± 2 mK temperature control,
 dsPIC μ controller & SD card

**Now: Shoebox sized
field demonstrator**



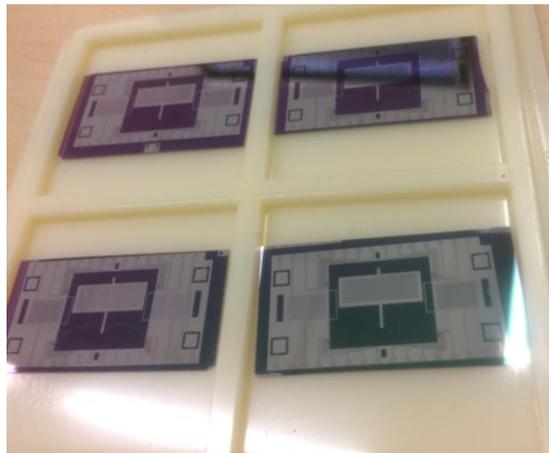
**10 kg, 3.2 W, 15 hours battery
 ± 2 mK temperature control,
dsPIC μ controller & SD card**

**Next: Standard MEMS
vacuum package**

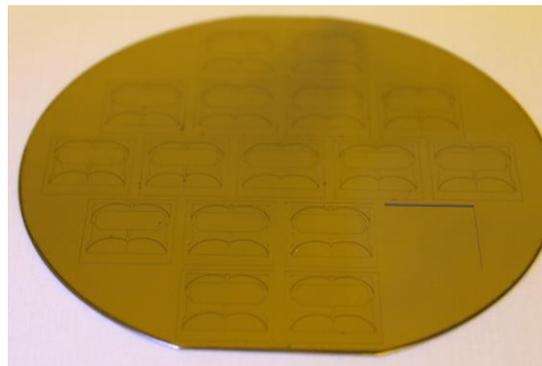


**Aim: < 1 kg, < 3.2 W
24 hours battery**

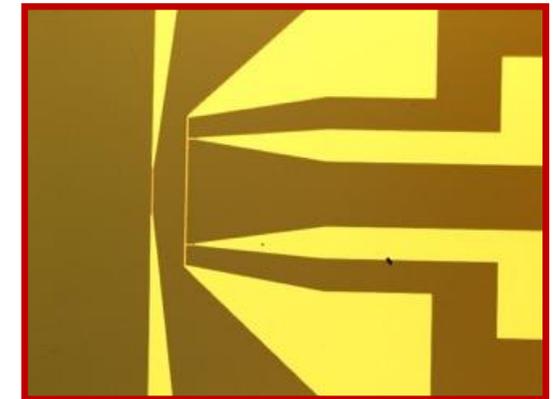
- Capacitive sensing brings down the size of the platform, helps in more efficient
- Capacitive read-out is 10 times more sensitive than the optical read-out
- To be used with the optical sensor and interferometric read-out for stabilizing the proof mass (force-feedback)
- We are working with KNT to mass produce the sensors



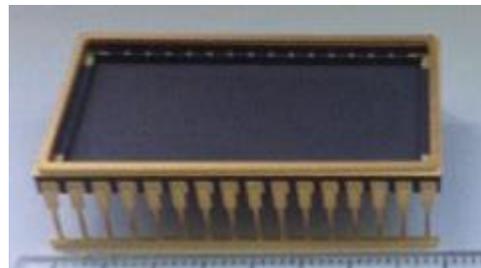
An image of the capacitive electrodes that will be used to measure the displacement of the MEMS



Wafer scale fabrication to improve yield

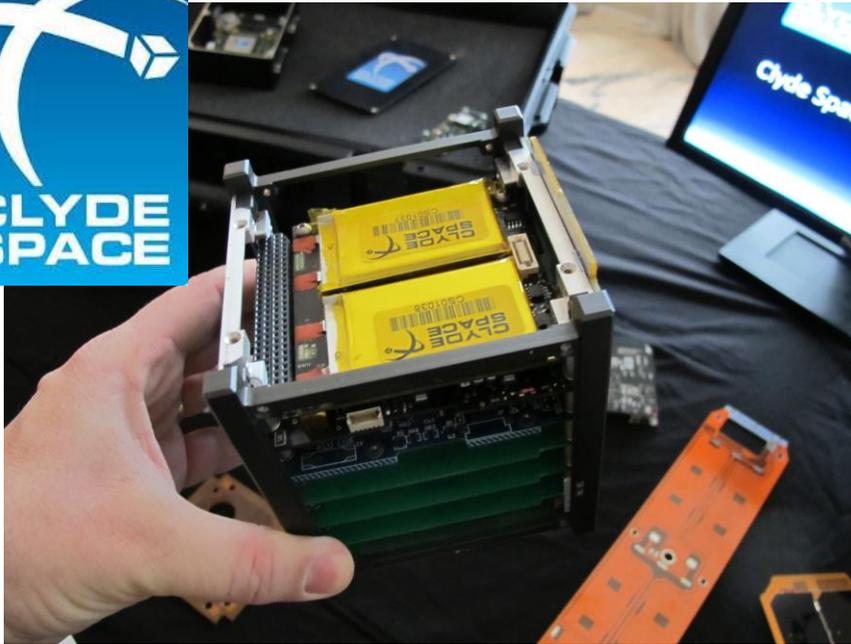


On-chip temperature control



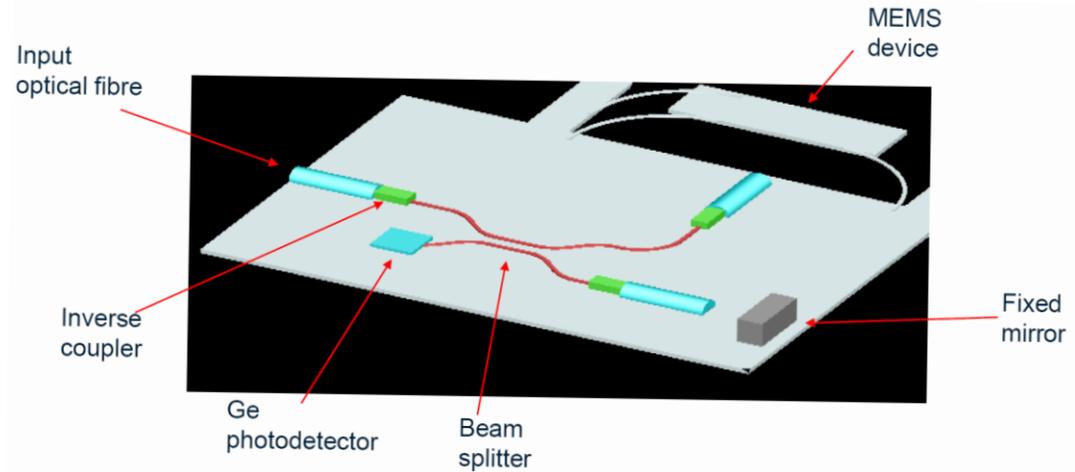
MEMS Package





Attitude control (EngD/CENSIS)

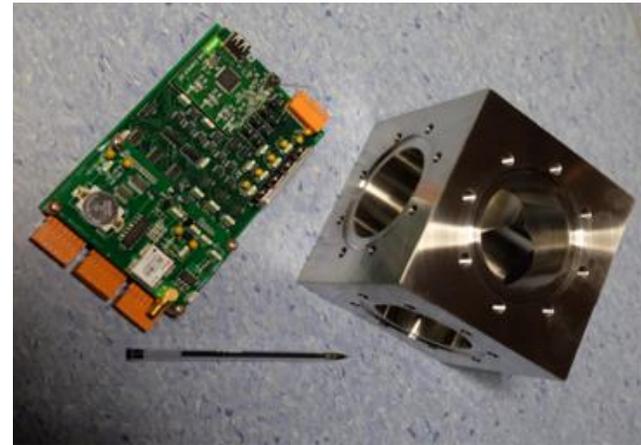
Schlumberger



Miniature interferometric sensing



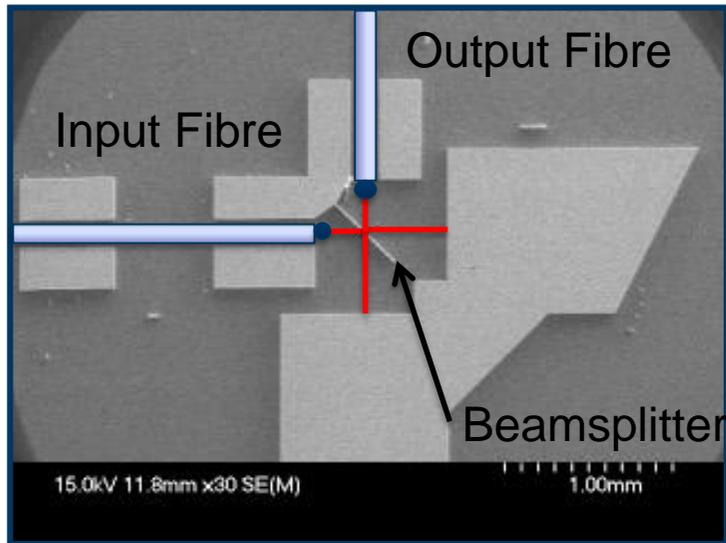
Underwater sensing



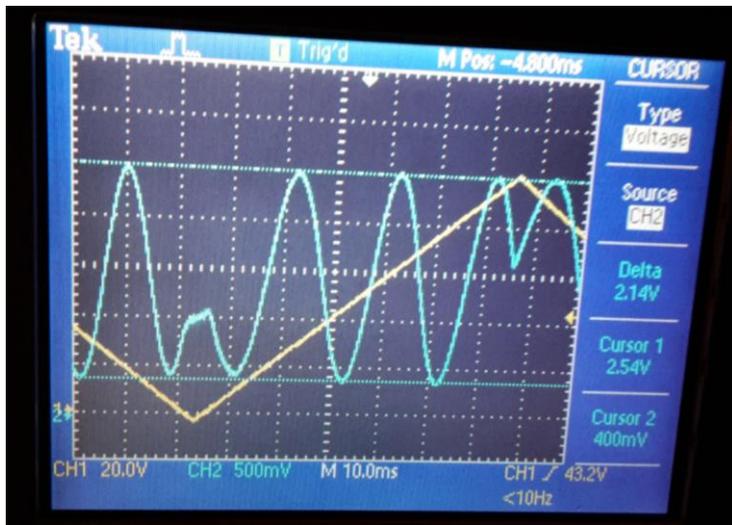
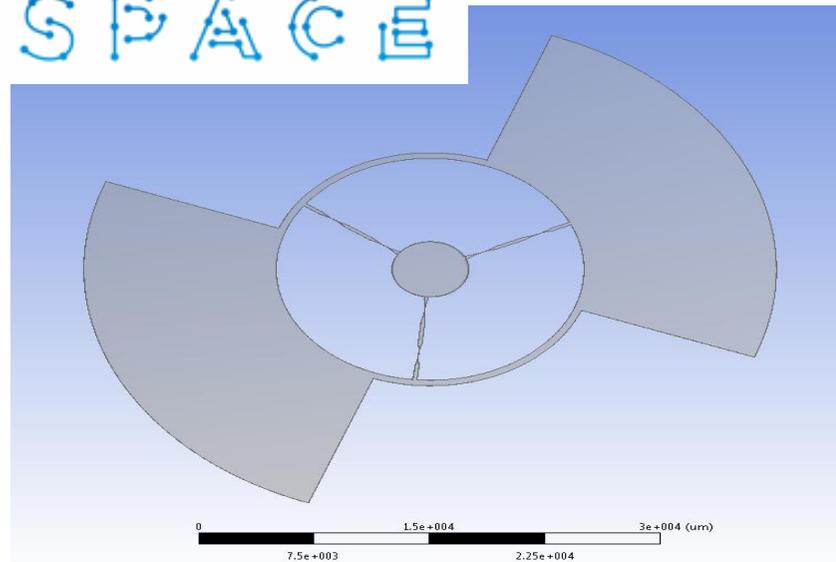
Field prototype



- Achieving 10 pm sensitivity at frequencies above 1 Hz
- Schlumberger in-vacuum interferometer
- DSTL: silicon guided interferometer

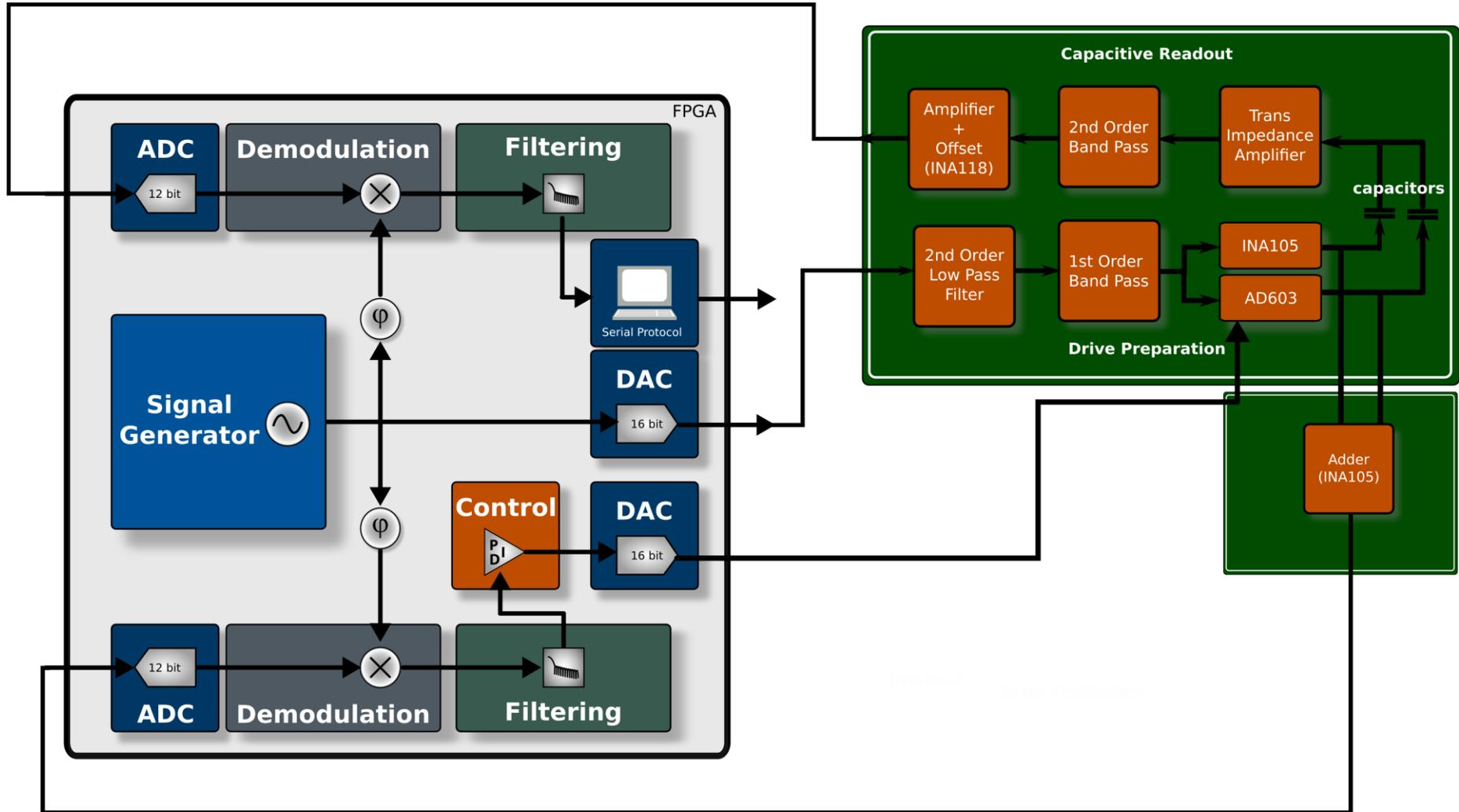


CLYDE
SPACE



- Developing gradiometers with sensitivity aimed at 10 Eotvos/ $\sqrt{\text{Hz}}$
- Capacitive readout and electrostatic closed loop control

Lock-In Readout on FPGA



Measured long term sensitivity: $< 0.5 \frac{aF}{\sqrt{Hz}}$ $3\sim 5 \frac{ng}{\sqrt{Hz}}$

Andreas Neukirch 05/18

- Field tested portable MEMS gravimeters
- Working with partners (KNT, Optocap) to deliver Vacuum packaged devices
- Engagement with end-users across Oil & gas, environmental monitoring/volcanology, security & defence, space
- Deployment of 80-100 MEMS Gravimeters around Mt. Etna in the coming year for multi-pixel gravity imaging (FET Open EU Grant)
- Working towards developing an on-chip interferometric MEMS Gravimeter

Schlumberger

QinetiQ

Innovate UK

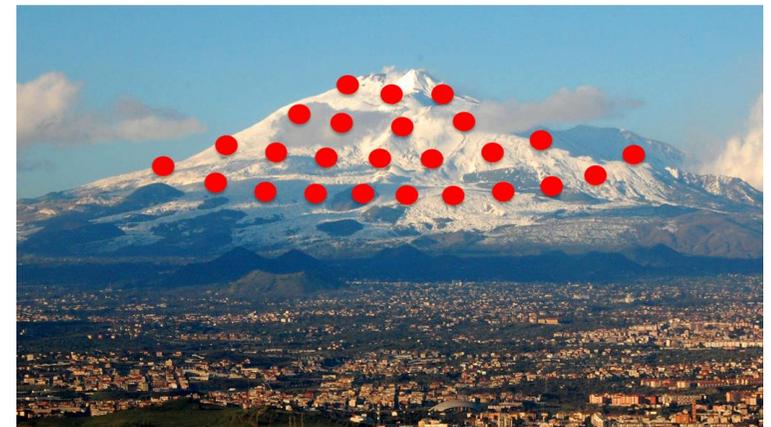


X_m KAIAM

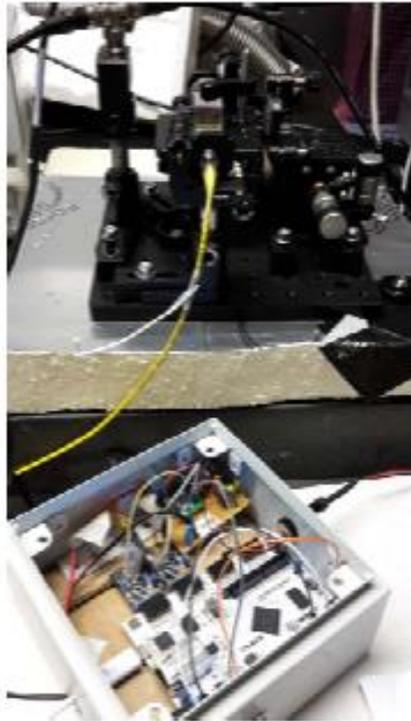
IQE



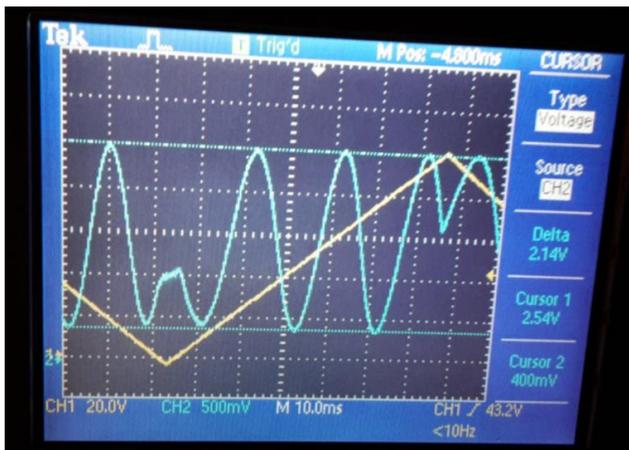
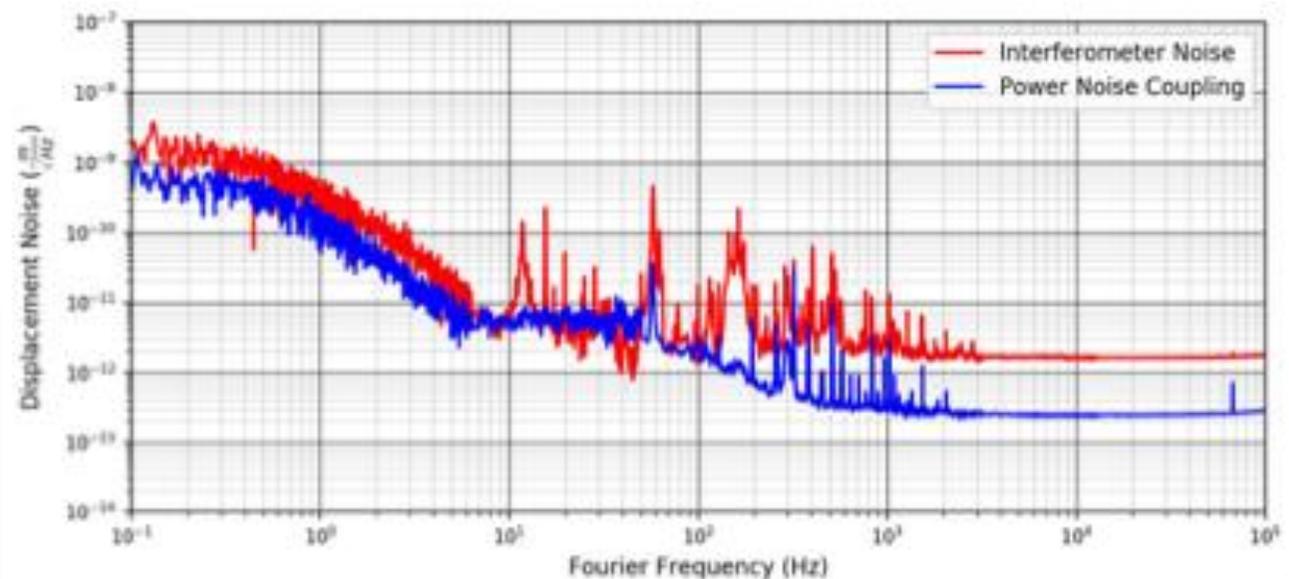
optocap



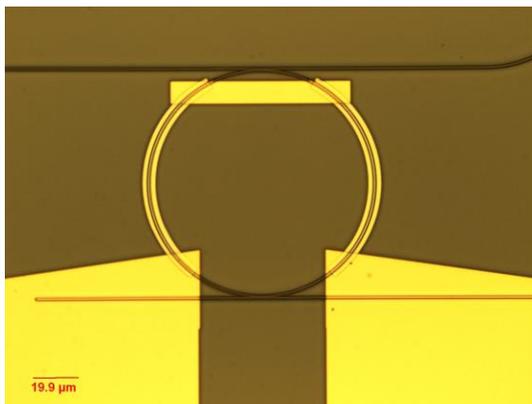
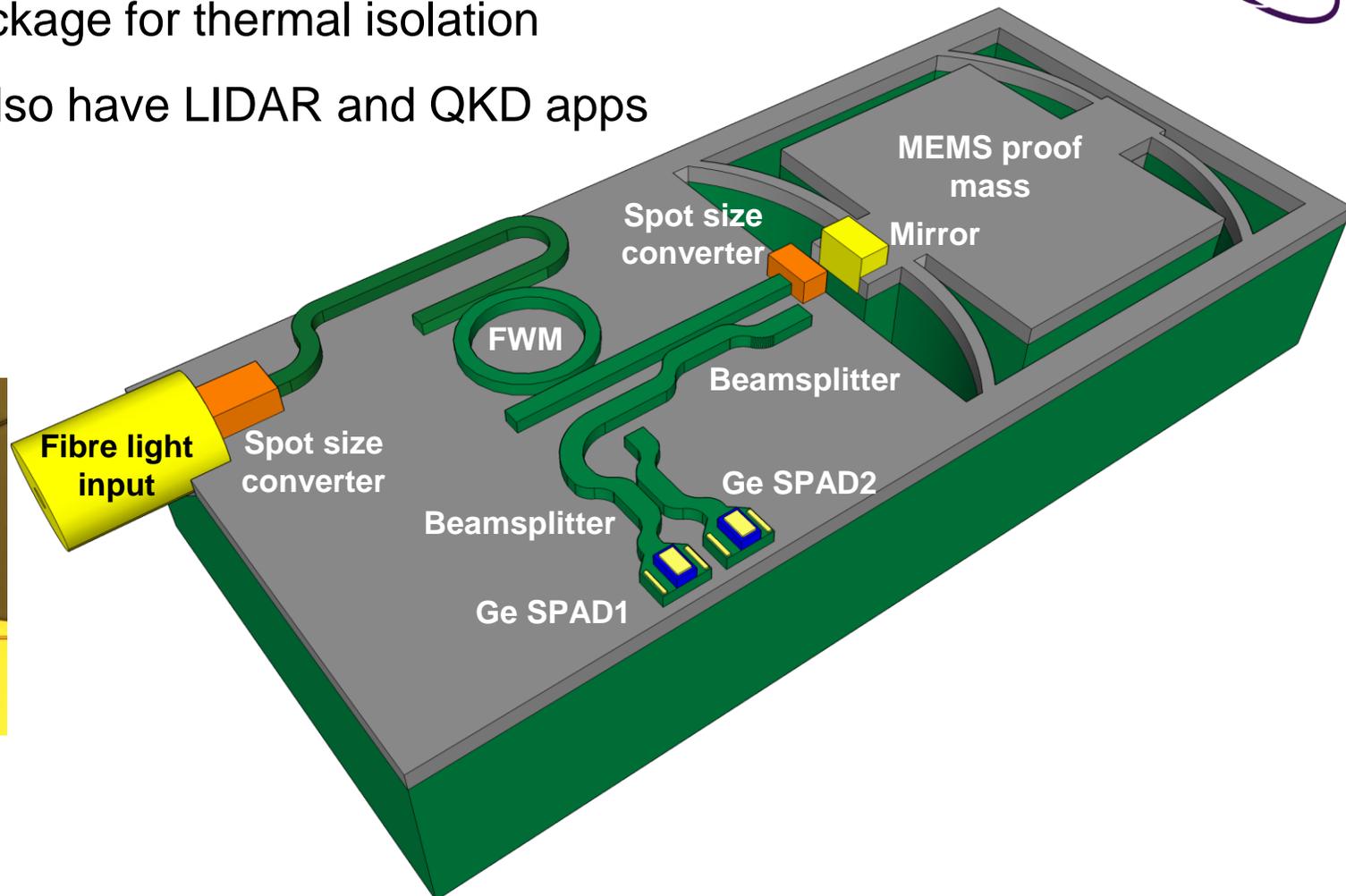
Bench Top Interferometer



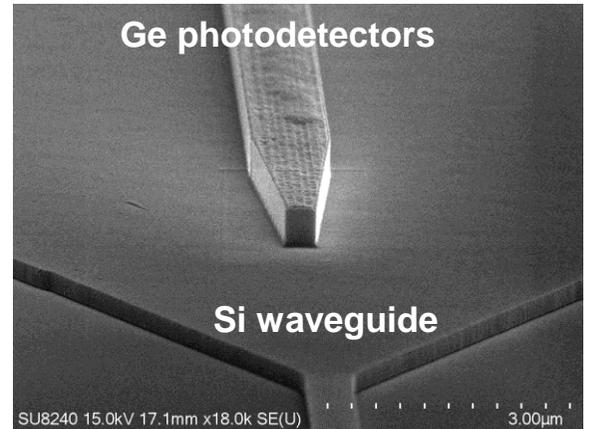
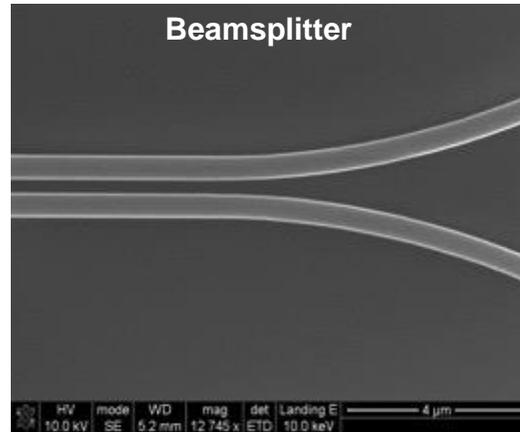
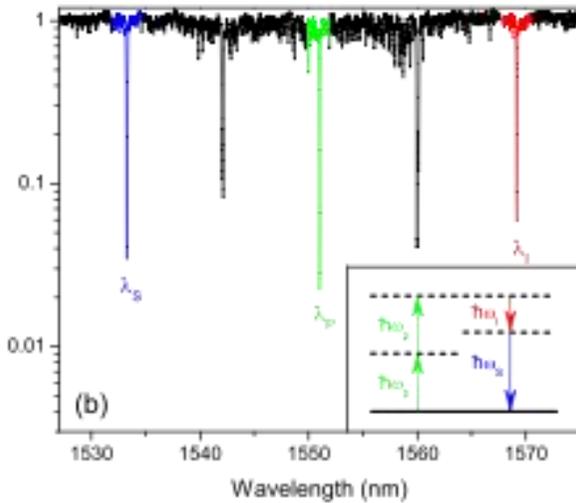
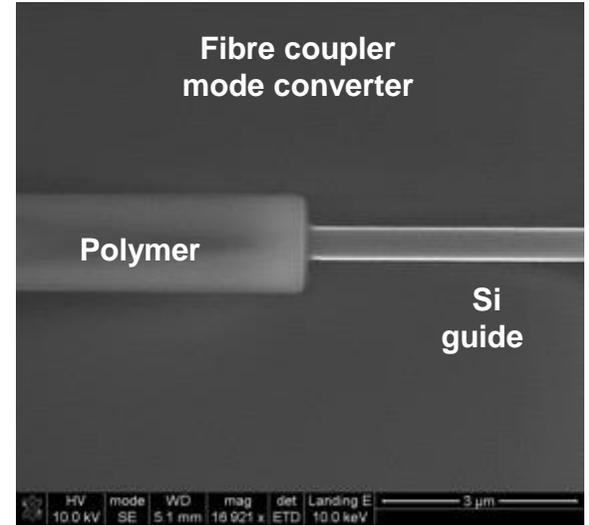
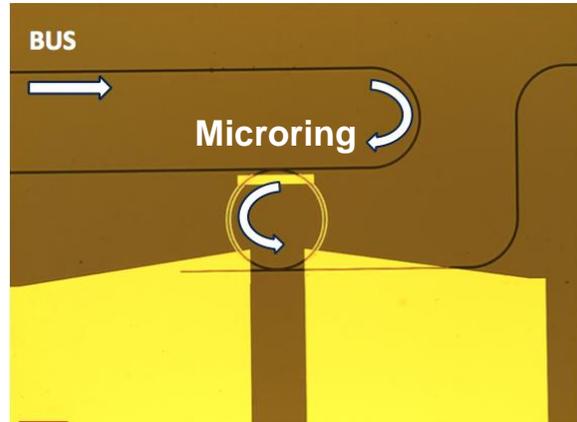
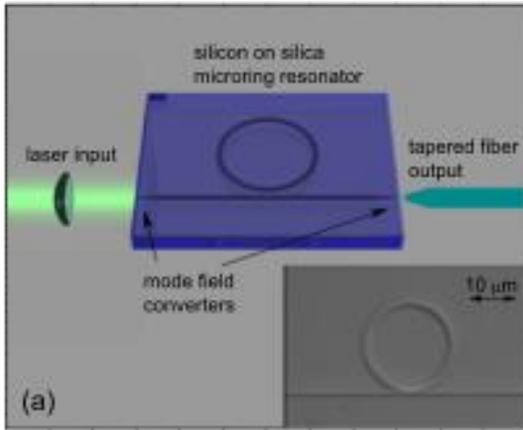
- Bench top interferometer with FPGA digital control loop to lock at mid-fringe
- $2 \text{ pm}/\sqrt{\text{Hz}}$ measurement is 3 orders of magnitude lower than shadow sensor
- Limited by power noise
- Electronics already available for interferometer



- Integrated Michelson interferometer with squeezed light on a chip
- Off-chip laser to reduce thermal noise
- MEMS vacuum package for thermal isolation
- Ge-on-Si SPADs also have LIDAR and QKD apps

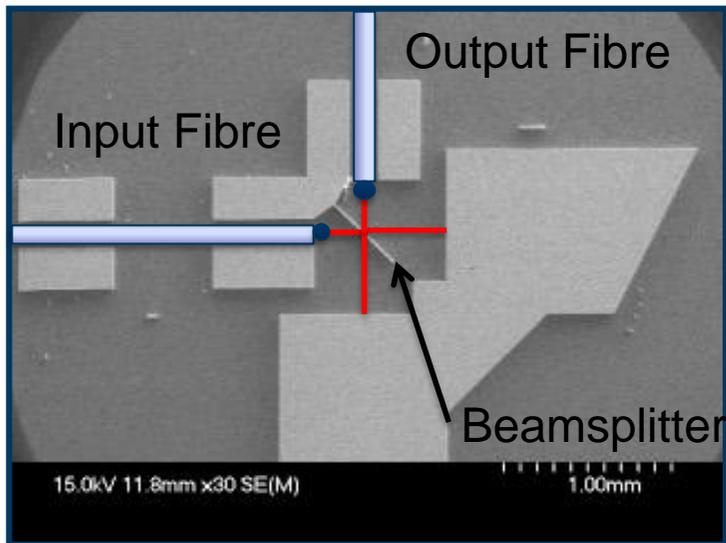


Components of SLAM Gravimeter

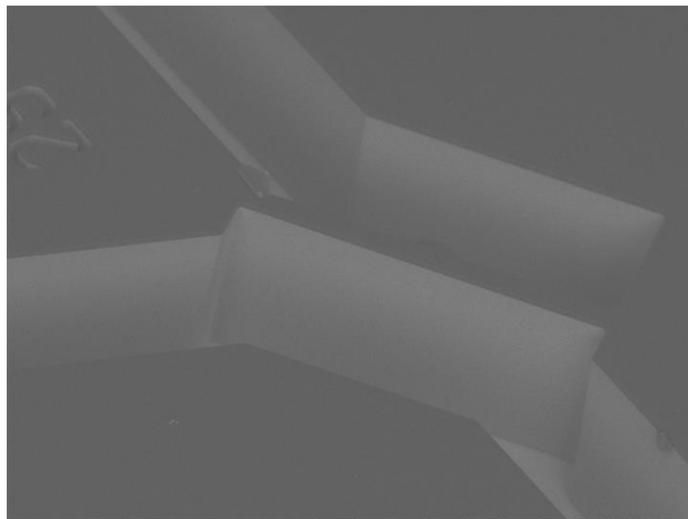


Optica 2, 88 (2015)

IEEE Trans. Elec. Dev. 60, 3807 (2013)



- Combining the sensitivity of interferometer and small scale of MEMS
- Free-space interferometric displacement read-out
- Single step process to etch out proof mass, mirrors and splitters
- Schlumberger: in-vacuum interferometer
- DSTL: silicon guided interferometer



2017/08/23 17:01 L x300 300 um

Schlumberger

[dstl]

